



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicants: Thomas L. Ritzdorf, *et al.*)
Serial No.: 09/386,734)
Filed: August 31, 1999)
For: METHOD AND APPARATUS FOR LOW-)
TEMPERATURE ANNEALING OF)
METALLIZATION MICROSTRUCTURES)
IN THE PRODUCTION OF A)
MICROELECTRONIC DEVICE)

Group Art Unit: 1753

Examiner: not assigned

Attorney Docket No.:
SEM4492P0082US

1742

GROUP 1700

AUG 23 2000

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Attached Form PTO/SB/08A lists references which may be considered to be material to the above-identified application by the Patent Examiner. Copies of the references are enclosed. Entry into the record is respectfully requested.

Respectfully submitted,

By: 
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CERTIFICATE OF MAILING

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage at First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on August 11, 2000.

